

9. The manufacturing method of a glass substrate for a magnetic disk according to any one of claims 1 to 8, wherein after the step of forming a round hole in a glass substrate, a step of performing chamfering processing is carried out in the glass substrate.

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10. A manufacturing method of a magnetic disk characterized in that at least a magnetic layer is formed on a main surface of a glass substrate for a magnetic disk that can be obtained by the manufacturing method of a glass substrate for a magnetic disk according to any one of claims 1 to 9.

9. The manufacturing method of a glass substrate for a magnetic disk according to any one of claims 1 to 8, wherein after the step of forming a round hole in a glass substrate, a step of performing chamfering processing is carried out in the glass substrate.

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10. A manufacturing method of a magnetic disk characterized in that at least a magnetic layer is formed on a main surface of a glass substrate for a magnetic disk obtained by the manufacturing method of a glass substrate for a magnetic disk according to any one of claims 1 to 9.